



PATENT
2927-0155P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mitsunori Mike et al.

Conf: 6433

Application No.: 10/681,156

Art Unit: 2635

Filed: October 9, 2003

Examiner: Jayesh A. Patel

For: METHOD AND APPARATUS OF
MEASURING ROTATIONAL AND
FLIGHT CHARACTERISTICS OF SPHERE

AMENDMENT UNDER 37 C.F.R.1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 11, 2006, the period for response being extended by one month to April 11, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

This Paper includes Claim Set As Amended, Remarks and two Terminal Disclaimers.